Nation of Allowahility	Application No.	Applicant(s)	
	10/540,731	TAUNIER ET AL.	
Notice of Allowability	Examiner	Art Unit	
	Edna Wong	1753	
The MAILING DATE of this communication apperature All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this apport or other appropriate communication IGHTS. This application is subject to	plication. If not included will be mailed in due course. THIS	
1. \boxtimes This communication is responsive to <u>Amendment dated M</u>	a <u>y 15, 2007</u> .		
2. The allowed claim(s) is/are 11-20.			
3. ☐ Acknowledgment is made of a claim for foreign priority unal ☐ All bl ☐ Some* cl ☐ None of the:			
1. Certified copies of the priority documents have been received. 2. Contified copies of the priority documents have been received.			
2. Certified copies of the priority documents have been received in Application No			
3. Copies of the certified copies of the priority documents have been received in this national stage application from the			
International Bureau (PCT Rule 17.2(a)).			
* Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		complying with the requirements	
4. A SUBSTITUTE OATH OR DECLARATION must be subminFORMAL PATENT APPLICATION (PTO-152) which give			
5. CORRECTED DRAWINGS (as "replacement sheets") must be submitted.			
(a) including changes required by the Notice of Draftspers		948) attached	
1) 🗌 hereto or 2) 🔲 to Paper No./Mail Date		,	
(b) including changes required by the attached Examiner' Paper No./Mail Date	s Amendment / Comment or in the C	Office action of	
Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in t			
6. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.			
AM-show M			
Attachment(s) 1. ☐ Notice of References Cited (PTO-892)	5. Notice of Informal P	Patent Application	
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. ☐ Interview Summary	• •	
3. Information Disclosure Statements (PTO/SB/08),	Paper No./Mail Dat	Paper No./Mail Date 7. Examiner's Amendment/Comment	
Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. 🛭 Examiner's Stateme	ent of Reasons for Allowance	
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		Samona	
•		EDNA WONG PRIMARY EXAMINER	

Application/Control Number: 10/540,731

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REASONS FOR ALLOWANCE

The following is an examiner's statement of reasons for allowance:

Claims 11-20 are allowable over the prior art of record because the prior art does not teach or suggest a method of producing a I-III-VI_y compound in thin film form by electrochemistry, in which y is close to 2, VI is an element comprising selenium, I is copper, silver or gold and III is boron, aluminum, gallium, indium or thallium, comprising the steps of (a) providing, (b) applying and (c) regenerating as presently claimed, esp., the step of regenerating the selenium in active form in the electrolysis bath.

The prior art does not contain any language that teaches or suggests the above.

Nakamura et al. teaches the electrodeposition of Cu-In-Se films with an aqueous solution containing CuCl₂, InCl₃ and SeO₂ (abstract). Nakamura et al. do not teach regenerating the selenium in active form in the electrolysis bath.

Wang et al. teaches that Se can be re-oxidized to Se(IV) by H_2O_2 (abstract). Wang et al. do not teach electrolysis or an electrolysis bath.

Therefore, a person skilled in the art would not have been motivated to adopt the above conditions, and a prima facie case of obviousness cannot be established.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled

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"Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Edna Wong whose telephone number is (571) 272-1349. The examiner can normally be reached on Mon-Fri 7:30 am to 4:00 pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nam Nguyen can be reached on (571) 272-1342. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

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Edna Wong
Primary Examiner
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EW June 4, 2007